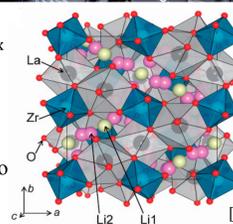
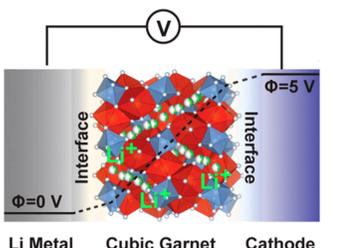


**ABSTRACT:** Recently, lithium-ion batteries became of a great interest in industry due to their high energy density and reasonable price. Garnet-type electrolytes (e.g., LLZTO) can be of great contribution to these batteries due to their outstanding properties. In this research, LLZTO thin film was deposited using Pulse Laser Deposition (PLD) technique, which is based on physical vapor deposition. An LLZTO pellet (target for PLD) was re-grounded and a new pellet was produced, using uniaxial dry pressing followed by sintering and X-ray Diffraction (XRD) analysis. The LLZTO film was deposited on a stainless-steel substrate at 500 °C for 40 min. The oxygen partial pressure was 75 mTorr with an energy of 452 mJ. The XRD of the target/pellet before PLD was generally good and matched with literature. After the PLD, generally LLZTO was not deposited. However, it is still cannot be concluded that LLZTO was not deposited, as the peaks between angles 40° to 60° match with the original LLZTO target, so it may be that the peaks of stainless-steel and LLZTO on stainless-steel had interfered. However, this needs more investigation and evaluation in order to give a final conclusion.

## Background & Motivation

- Lithium-ion batteries (LIB) are considered to have high energy density and reasonable price [1]
- However, current liquid LIBs have the risk of leakage [1] and flammability [2]
- For future solid-state LIBs, LLZTO is one of the candidates
- Garnet-type electrolytes (e.g., LLZTO) are considered to have great energy density, high temperature stability, electrochemical stability and safety [3]
- Thin films have better properties, due to morphology, composition and structure [4]
- Thin films are more applicable and can cover large areas (contact area)

### Garnet-Based Solid-State Batteries



- Lithium lanthanum zirconium tantalum oxide ( $\text{Li}_{7-x}\text{La}_3\text{Zr}_{2-x}\text{Ta}_x\text{O}_{12}$ ) is modified version of  $\text{Li}_7\text{La}_3\text{Zr}_2\text{O}_{12}$  (LLZO)
- Ta occupies some of the Zr sites and helps maintaining a cubic structure [3]
- Cubic structure has higher conductivity (can reach to  $10^{-4}$  S/cm at RT) than tetragonal structure [3]

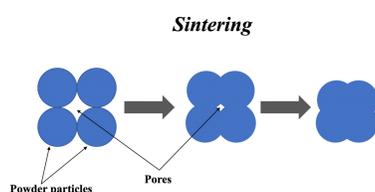
## Introduction

### Aims:

- To re-synthesize an LLZTO target
- Mainly:** Depositing thin films of LLZTO
- Characterizing LLZTO thin film properties

### Sintering

- Densification and improving mechanical properties

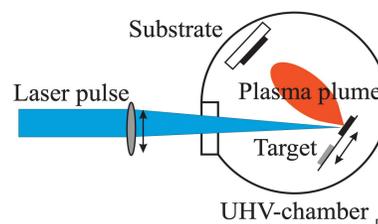


### X-ray Diffraction (XRD)

- Used to check the crystal structure, impurities and phases

### Pulse Laser Deposition (PLD)

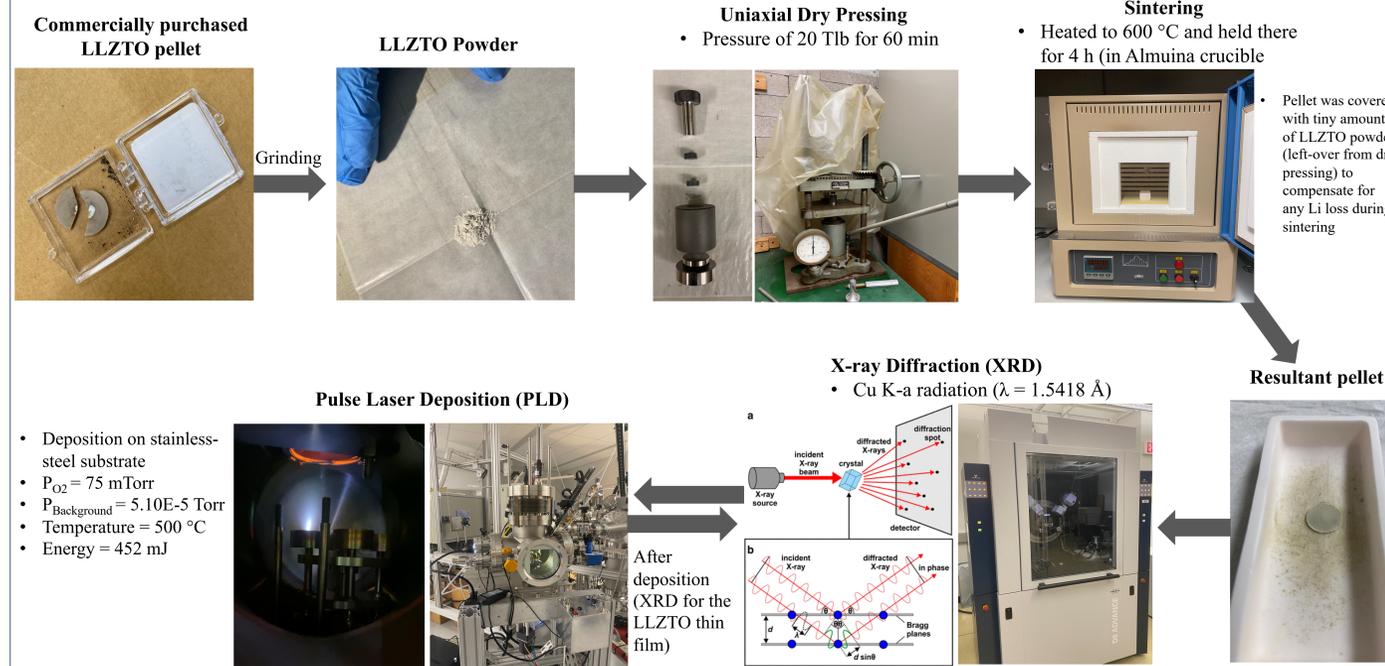
- Based on physical vapor deposition (PVD). In a high-vacuum chamber, a beam of laser strikes the sample. The sample will evaporate as plasma plume and then deposited as a thin film on a substrate [6]



### Hypotheses:

- During re-synthesizing, samples may break
- In general, the deposition may be challenging
- Different substrates need to be examined
- High temperatures will cause Li loss, due to Li volatility

## Procedures



## Conclusions

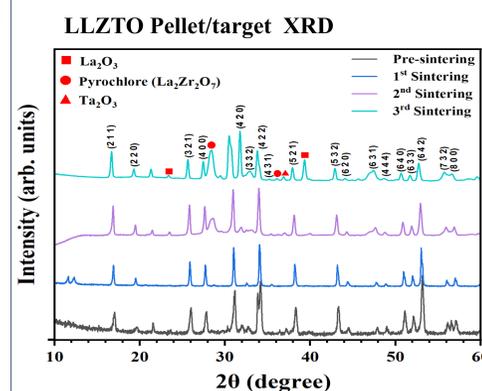
- As expected, high temperatures results in losing Li, as Li tend to escape the sample due to its high volatility. Therefore, phases may be affected
- The final Li content can be said to be 6.2 mol, based on literature
- The overall LLZTO deposition did not work quite well
- However, there were some peaks between the angles 40° to 60° that almost matched with the original LLZTO target's XRD
- These peaks can also be an interference between the the stainless-steel substrate XRD and the LLZTO XRD, but more investigation needs to be done in order to get better conclusion

## Future Work

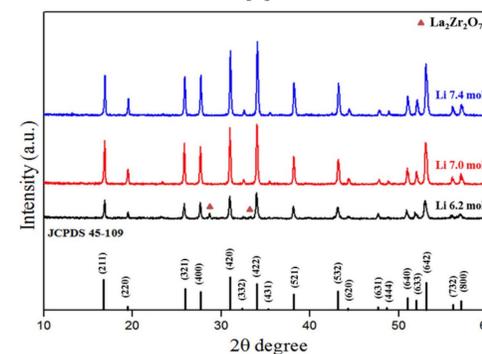
- Repeat the experiment in order to get more accurate data
- Do more investigation using X-ray Photoelectron Spectroscopy (XPS)
- Examining different substrates, like MgO,  $\text{Al}_2\text{O}_3$ , Cu foil, etc.
- Trying different deposition conditions, manipulating temperature, pressure, deposition period, etc.
- Characterizing the LLZTO thin film and its properties
- Working to deposit epitaxial thin films of LLZTO

## Results and Discussion

### X-ray Diffraction (XRD)

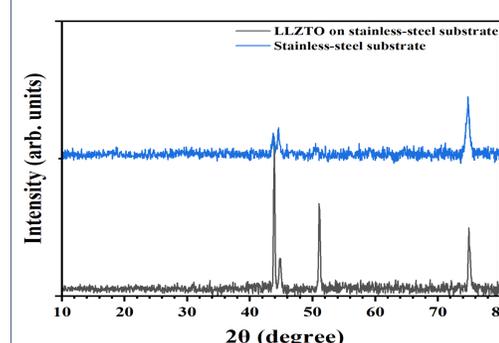


### XRD from Yoon et al. [1] for LLZTO Pellet/target



- All Peaks match with some additional peaks, which is quite expected, as the exposure to high temperatures will cause Li loss, due to it volatility.
- 1<sup>st</sup> sintering almost matched with the Li 7.4 mol, 2<sup>nd</sup> and 3<sup>rd</sup> sintering a mostly matched the Li 6.2 mol (expected)
- Shifts and minor shifts between scans can be due to the pellet/sample height difference (as examined)

### XRD of LLZTO on stainless-steel after PLD



### LLZTO on stainless-steel after PLD



- Generally, the deposition did not work well
- However, the peaks between the angles 40° to 60° almost matched with the original LLZTO target's XRD
- This may be an interference between the stainless-steel substrate's peaks with the deposited LLZTO peaks
- More testing and investigation needs to be done in order get a clear and final conclusion (like X-ray Photoelectron Spectroscopy (XPS) which helps in analyzing the surface)

## References

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